

**REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 3723****PATENT
5298-07600/PM01036****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**In re Application of:
Zagrebelny

Serial No. 10/025,511

Filed: December 19, 2001

For: **METHODS FOR POLISHING A
SEMICONDUCTOR TOPOGRAPHY**Group Art Unit: 3723
Examiner: Robert Rose

Atty. Dkt. No. 5298-07600

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September 30, 2004
Date

Kevin L. Daffler

**SUPPLEMENTAL AMENDMENT; RESPONSE AFTER FINAL REJECTION
PURSUANT TO 37 CFR § 1.116****Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313**

Dear Sir/ Madam:

This paper is submitted in response to the final Office Action dated June 2, 2004 and the Advisory
Action dated August 25, 2004 to further highlight reasons why the application is in condition for
allowance.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 4 of this paper.

Remarks begin on page 7 of this paper.

SN 10/025,511 Supplemental Response to Final Office Action Mailed 6/2/2004

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